			ent of Commerce		Attorney Docket No. 5308-395		Serial N To be as	Serial No. 10/790406 To be assigned	
LIST OF DOCUMENTS CITED BY APPLICANT Applicant:					Applicant: O'	Loughlin et al.			
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A	. 4	U.S. Application Serial No. 10/414,787 entitled Methods and Apparatus for Controlling Formation of Deposits in a Deposition System and Depositions Systems and Methods Including the Same, filed April 16, 2003.							
. 30	5	U.S. Application Serial No. 09/756,548, titled Gas Driven Rotation Apparatus and Method for Forming Silicon Carbide Layers, filed January 8, 2001.							
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